

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application

Applicants: Satoshi Komiya et al.

Serial No.: 10/679,031

Filed: October 3, 2003

For: **EPITAXIAL SILICON WAFER**

Examiner: Matthew J. Song



) Art Unit: 1765
) Confirmation No.: 1669
)
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AMENDMENT, Commissioner for Patents, P.O. Box
1450, Alexandria, Virginia 22313-1450, on
September 9, 2005

Gerald T. Shekleton
Gerald T. Shekleton Reg. No. 27,466

AMENDMENT

Mail Stop: AMENDMENT
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The Office Action of March 15, 2005 has been carefully reviewed and the following
amendments and remarks are made in response thereto.

09/14/2005 MWOLGE1 00000018 10679031

01-FC:1203
02 FC:1201

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